

DE LA RECHERCHE À L'INDUSTRIE





# STATUS OF THE PREPARATION FOR THE LEM (AND ANODE) PRODUCTION

A. Delbart, M. Karolak, E. Mazzucato, S. Murphy, M. Zito
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www.cea.fr

Technical Board vidyo meeting, october 19th, 2016



## **INTRODUCTION / OUTLINE**



- Review of the LEM production sequence
- Technical specifications document for the LEM production call for tender
- Comparison of performances of LEMs produced by ELTOS (It) and ELVIA (Fr)
- Status of the LEM cleaning and testing equipments at Saclay
- Anode PCB specifications
- Conclusion



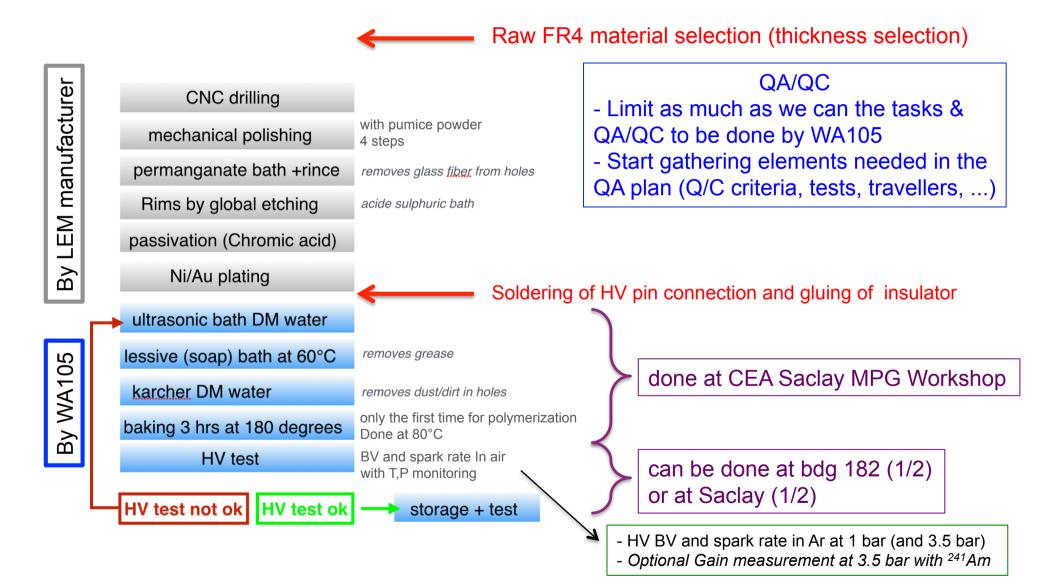
# IDENTIFIED LEM MANUFACTURING CIES WA.105 ELVIA CIE (COUTENCES, FRANCE) & ELTOS (IT)

- Gathering of informations from the THGEM community, Sebastien M., CERN MPGD workshop, and ELTOS to derive the guidelines for LEM manufacturing according to the know-how on THGEM production.
- First contact with ELVIA in march and delivery on april 25<sup>th</sup> of four 10x10 cm<sup>2</sup> LEMs: Breakdown Voltage (BV) tests in ambient air at Saclay MPGD workshop, before and after "Saclay" cleaning procedure + gain measurement @ 1 bar (241Am)
- → as good as ELTOS 10x10 cm<sup>2</sup> LEMs and even better after cleaning (BV≈4500 V)
- Meeting at ELVIA Coutences site on may 9<sup>th</sup> to review the "actual" procedure followed by ELVIA and set the procedure for the production of four 50x50 cm<sup>2</sup> LEMs
  - Procurement & selection of raw FR4 plates for < 4% thickness uniformity
  - Add a mechanical "polishing" step (before Ni/Au) for 2 of the 4 LEMs
- Four 50x50 cm<sup>2</sup> "3x1x1 WA105" LEMs produced and received on june 29<sup>th</sup>:
  - BV test in test box filled with synthetic air and 5.0 Argon (LEM "as received")
  - As good as the 25x25 cm<sup>2</sup> ELTOS "Saclay cleaned" LEMs
  - <u>To be done</u>: test again after "Saclay cleaning" and perform gain measurement in HP vessel in 5.7 argon at 1 bar & 3.5 bar.
- We (Eddy & myself) had a meeting at ELTOS on july 25<sup>th</sup> to review the LEM prod.



# LEM MANUFACTURING PROCEDURE AS OF JANUARY 2016







# LEM MANUFACTURING PROCEDURE QA/QC IN LEM MANUFACTURING COMPANY



Procurement of raw material in one batch at the beginning of the contract

with pumice powder

acide sulphuric bath

removes glass fiber from holes

4 steps

Raw FR4 material selection (thickness selection)

By LEM manufacturer

By WA105

#### CNC drilling

mechanical polishing

permanganate bath +rince

Rims by global etching

passivation (Chromic acid)

Ni/Au plating

**QA/QC** in LEM manufacturing company

- Standard PCB QA/QC with A.O.I
- Measurements of thicknesses and rim dimensions on metallographic sections associated to each produced LEM
- Optional HV test in ambient air

Soldering of HV pin connection and gluing of insulator

ultrasonic bath DM water

lessive (soap) bath at 60°C

karcher DM water

baking 3 hrs at 180 degrees

**HV** test

HV test not ok

HV test ok

removes grease

removes dust/dirt in holes

only the first time for polymerization Done at 80°C

BV and spark rate In air with T,P monitoring

storage

done at CEA Saclay MPG Workshop

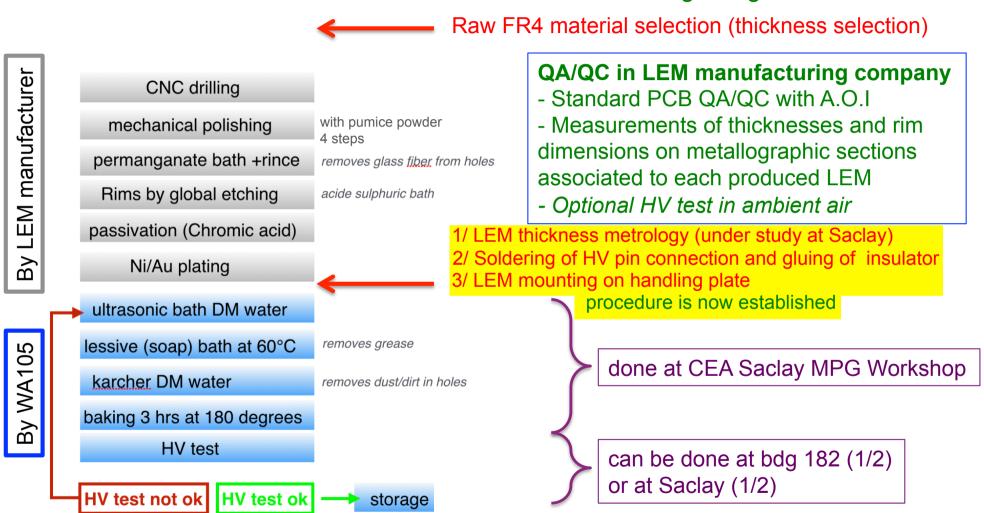
can be done at bdg 182 (1/2) or at Saclay (1/2)



# LEM MANUFACTURING PROCEDURE FIRST TASKS ONCE LEM DELIVERED



Procurement of raw material in one batch at the beginning of the contract

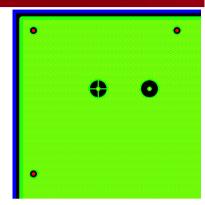


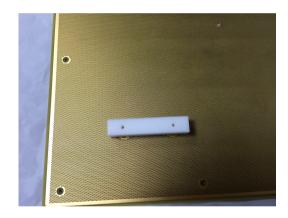


# HV CONNECTIONS: DESIGN MODIFICATIONS WA 105 TOOLING FOR HV PIN SOLDERING & INSULATOR GLUING

The proposed procedure was tested on 25x25 & 50x50 prototypes

- Solder pins with Core 230 no-clean wire solder
- Use of a dedicated tool to position and maintain pins while soldering
- Modified LEM PCB copper pattern and through hole diameter
- Gluing of the POM insulating cylinders with 2010 Araldite using a centering tool

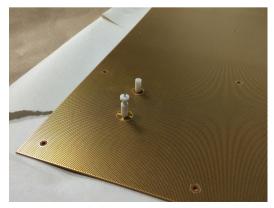


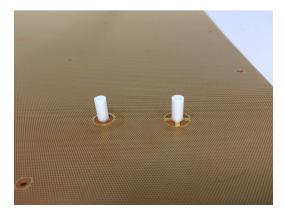










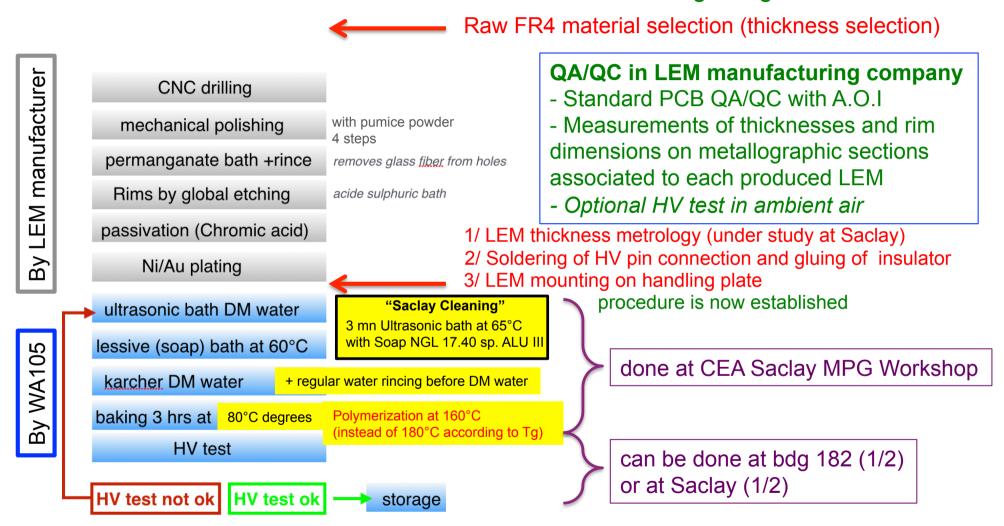




# LEM MANUFACTURING PROCEDURE « SACLAY CLEANING »



Procurement of raw material in one batch at the beginning of the contract

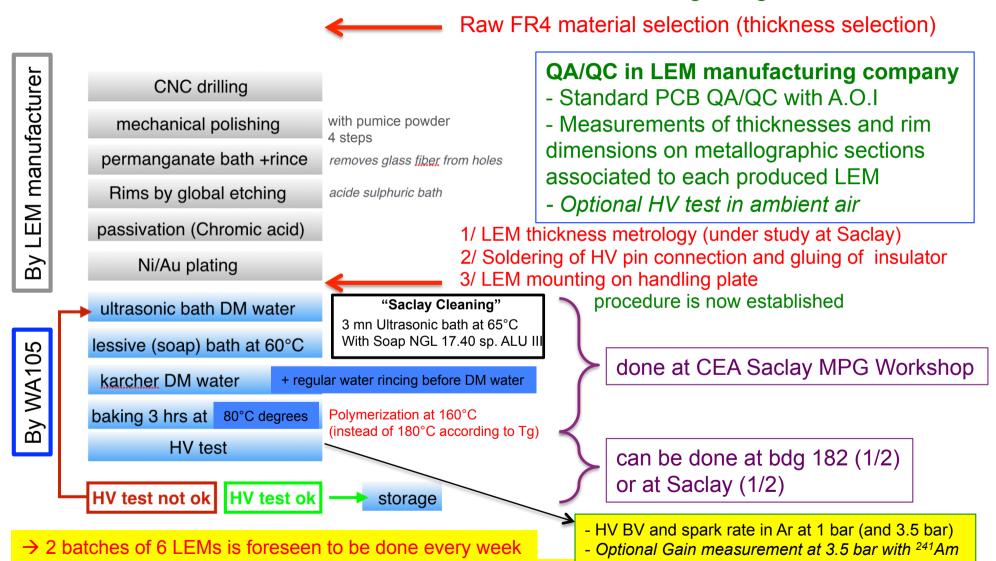




# LEM MANUFACTURING PROCEDURE LEM TESTS AND VALIDATION



Procurement of raw material in one batch at the beginning of the contract



→ Dismounting from handling plate → LEM mounting on anode PCB (?) → packaging & shipping



# TENDERING PROCESS FOR ½ PRODUCTION LEM SPECIFICATIONS



After discussions at Irfu and given the very tight schedule for the beginning of the CRP production for the 6x6x6, we believe it will be easier and quicker for us to go through a tendering process for half of the production of the LEMs through the "Service Commercial" in Saclay (instead of CERN procurement office).

Matière de base	Approvisionnement en un lot de fabrication en début de production
Matériau	Résine epoxy PANASONIC R-1755C (or R-1566W ? - ELVIA)
Dimensions	530 mm x 530 mm mini
Epaisseur de résine epoxy	1 mm (-0.04 /+0 mm selon les spécifications PANASONIC du lot)
Epaisseur de cuivre	105 μm
Epaisseur totale moyenne	1,21 (-0.04/+0) mm +/- 0.04 mm sur les 88 plaques sélectionnées
Uniformité d'épaisseur	+/- 0.04 mm (sur la surface de la plaque de base sélectionnée)
PCB LEM fini	
Dimensions	499.5 mm x 499.5 mm +0/-0.2 mm
Couche de finition Ni/Au	OUI : 5 μm Ni + 0.1 μm Au
Sérigraphie	OUI (si choisie pour marquage d'identification du circuit)
Vernis épargne	NON
Epaisseur finale (Ni/Au compris)	1.15 (-0.04/+0) mm +/- 0.04 mm (moyenne sur 88 LEM et
	uniformité sur la surface du LEM)
Trous « actifs » avec RIM	≈ 400 000 trous non-métallisés de diamètre 0.5 mm
RIM (fini avec Ni/Au)	40 μm +/- 4 μm



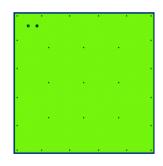
# LEM SPECIFICATIONS DOCUMENT (FRENCH DOCUMENT)

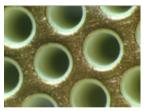


Irfu	Cahier des charges	Réf : CdCLEMWA105Fr
œ	LEM DU PROTYPE WA105 (DUNE/DP)	Date création : 30/09/2016
saclay	LEM DO PROTTPE WATOS (DONE/DP)	Page 1 sur 20

#### CAHIER DES CHARGES ET DES SPECIFICATIONS TECHNIQUES

#### PRODUCTION DES LEM DU PROTOTYPE WA105 (DUNE/DP)





#### HISTORIQUE DES MODIFICATIONS

Version	Date	Pages modifiées	Motifs
DRAFT	30/09/2016	Création	Pour diffusion restreintes et corrections
DA			Pour diffusion initiale pour l'appel d'offre

	Rédacteurs	Vérificateurs	Approbateur	
Nom	A. DELBART	E. MAZZUCATO	Y. PENICHOT	M. ZITO
Fonction	Chef de Projet	Resp. Physicien	Resp. QA	Resp. Scientifique
Date				
Visa				



#### LEM DU PROTYPE WA105 (DUNE/DP)

Réf : CdCLEMWA105Fr
Page 2 sur 20

#### Table des matières

1 - Introduction : le projet WA105 (démonstrateur DUNE/DP)	
3 - Objet	
3.1 - Fourniture du Titulaire	
3.2 - Fourniture CEA	
I - Conditions générales	
4.1 - Définition des lots/phases	
4.2 - Suivi du contrat et du déroulement de la production	
4.3 - Responsabilité du Titulaire	
4.4 - Devoir d'alerte	
4.5 - Points d'arrêts	
4.6 - Sous-traitance	
4.7 - Inspection technique	
4.8 - Modifications	
4.9 - Outillages	
4.10 - Planning demandé	1
- Assurance Qualité	1
- Description technique du LEM	1
- Directives de réalisation	1
7.1 - Fichiers gerber Tels Que Construits (TQC)	1
7.2 - Matériau de base : spécifications de la plaque d'epoxy cuivré	1
7.3 - Perçage	1
7.4 - « Desmearing »	1
7.5 - Polissage	1
7.6 - « Micro-etching » des RIM par le procédé de « Global Etching »	1
7.7 - Traitement de surface Nickel/or (Ni/Au)	
7.8 - Détourage du LEM à ses dimensions finales	1
7.9 - Nettoyage, rinçage, et étuvage	1
- Contrôles et tests	
8.1 - Procédure de contrôle de fabrication (incluse dans la LOFC)	
8.2 - Contrôles dimensionnels et sélection des plaques d'epoxy cuivré de base	
8.3 - Contrôle visuel et dimensionnel final du LEM	
8.4 - Contrôles et mesures sur les témoins pour coupes métallographiques	1
8.5 - Qualification sous tension des LEM (contrôle optionnel)	
- Recette & réceptions	
9.1 - Recette usine de la présérie	
9.2 - Recette des lots de production	
0 - Emballage / Transport	
10.1 - Général	
10.2 - Emballage	
10.3 - Transport	
1 - Contenu du dossier de fabrication et de Contrôles	
2 - Représentant CEA/Irfu	1
Annexe : liste des fichier gerber fournis par le CEA	2



# PROPOSED DELIVERY SCHEDULE FOR ½ PRODUCTION (4 MONTHS)



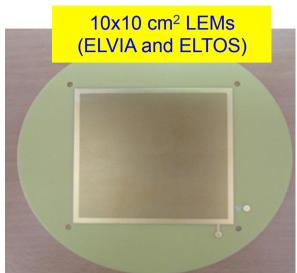
Schedule						
T0	Signature of the contract & kick-off meeting					
T0 + 2 weeks	Pre-production kick-off meeting Delivery of the LOFC (PAQ), gerber SAB, documentation as described in section 3.1					
T0 + 5 weeks	Pre-production Acceptance meeting for the delivery of the <b>8</b> pre-series LEM and associated documentation.					
T0 + 7 weeks	Production kick-off meeting and delivery of 3 batches of 24 LEM every 3 weeks. Decision for production of optionnal y<8 LEM before the start of the production of the last batch					
T0 + 16 weeks	Closing meeting					

- The List Of Manufacturing Operations and Controls (LOFC) and the Manufacturing Operations and Controls Traveller will be asked to the applicants with their offer and included as a criteria for company selection.
- The "Technical specifications" document is under discussion with the Commercial Division of CEA-Saclay. A "procurement officer" is identified and is currently preparing the documents for the call for tender. The invitation to tender may be published and opened in november for a selection of the company(ies) before christmas. Start of production will be triggered according to WA105 collaboration decision after test and qualification of the performances of the LEMs in the 3x1x1 prototype.

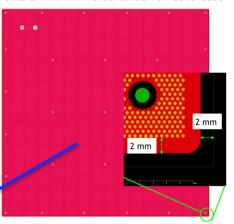


### THE LEMS PRODUCED AND TESTED



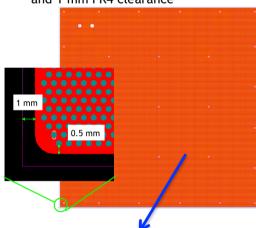


50x50 cm<sup>2</sup> LEM with 2 mm guard ring and 2 mm FR4 clearance for cold test

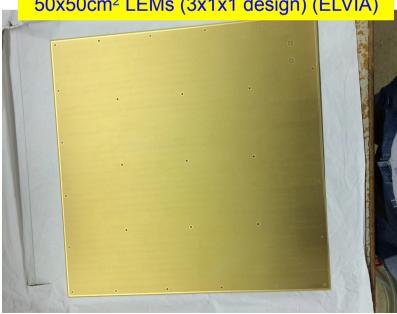


proposal:

50x50 cm<sup>2</sup> LEM with 0.5 mm guard ring and 1 mm FR4 clearance



50x50cm<sup>2</sup> LEMs (3x1x1 design) (ELVIA)



25x25cm<sup>2</sup> LEMs (ELTOS)





### 50X50 CM<sup>2</sup> ELVIA LEMS THICKNESS SELECTION AND RIM Q/C



Matière PANASONIC R-1566W

1mm diélectrique + cuivre 105/105

Lot: EP22534

В Ε

Avec Cuivre Diélectrique seul

	Α	В	С	D	E	moy
1	1100	1180	1170	1170	1200	1164
	900	980	970	970	1000	964
2	1200	1190	1200	1170	1150	1182
	1000	990	1000	970	950	982
3	1210	1180	1200	1140	1150	1176
	1010	980	1000	940	950	976
4	1200	1190	1170	1170	1150	1176
	1000	990	970	970	950	976
5	1200	1190	1170	1130	1160	1170
	1000	990	970	930	960	970
6	1170	1180	1200	1150	1180	1176
	970	980	1000	950	980	976
7	1200	1200	1160	1170	1140	1174
	1000	1000	960	970	940	974
8	1140	1190	1160	1160	1150	1160
	940	990	960	960	950	960
9	1190	1200	1160	1150	1150	1170
	990	1000	960	950	950	970
10	1200	1200	1190	1170	1150	1182
	1000	1000	990	970	950	982
11	1180	1190	1170	1150	1140	1166
	980	990	970	950	940	966
12	1160	1140	1100	1200	1150	1150
	960	940	900	1000	950	950
13	1200	1200	1170	1120	1100	1158
	1000	1000	970	920	900	958
14	1150	1120	1090	1200	1150	1142
	950	920	890	1000	950	942
15	1150	1170	1190	1140	1170	1164
	950	970	990	940	970	964
16	1200	1180	1170	1160	1130	1168
	1000	980	970	960	930	968
17	1180	1170	1140	1130	1100	1144
	980	970	940	930	900	944
18	1180	1170	1150	1140	1100	1148
	980	970	950	940	900	948
19	1180	1170	1160	1120	1110	1148
	980	970	960	920	910	948

#### RIM before Ni/Au finish (5 µm)



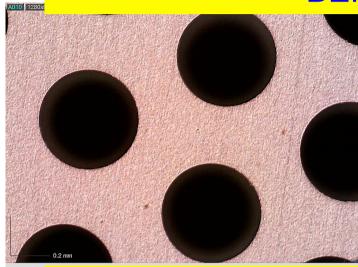
2 of the 4 LEMs were shipped to CERN and are currently under thickness metrology

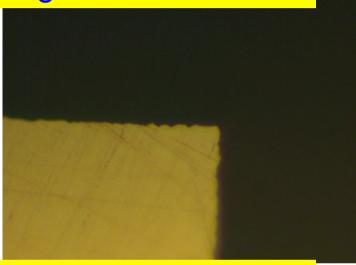


### 50X50 CM<sup>2</sup> ELVIA LEMS POLISHING



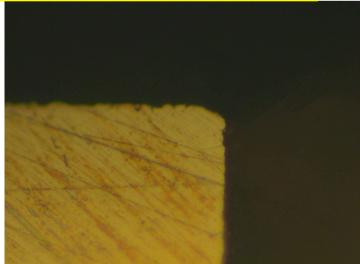
### **BEFORE** polishing





### **AFTER** polishing







### **BREAKDOWN VOLTAGE TESTS RESULTS**



- ELVIA uses PANASONIC R-1566W halogen free FR4 (130-140 °C Tg)
- ELTOS uses PANASONIC R-1755C halogen free FR4 (150 °C Tg)
- → Material choice for WA105 6x6x6?

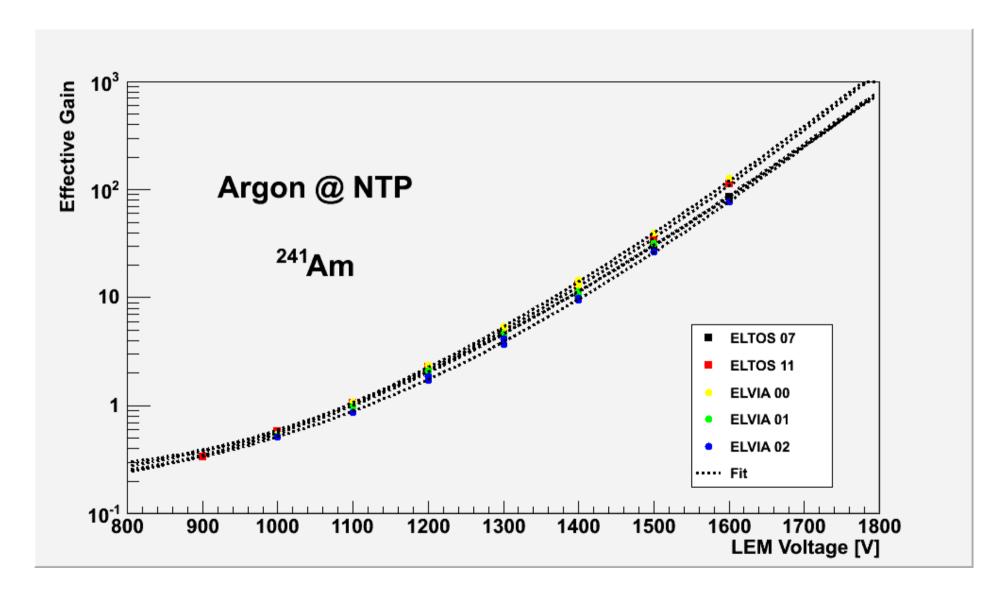
LEI	M	FR4 Measured	R4 Measured Breakdown Voltage in		Breakdown	Comments	
LEM type	LEM#	thickness (mm)	ambient air	in synthetic 5.0 air	Voltage in 5.7 Ar	Comments	
ELVIA 10x10 -	01	0.993	4500 V / < 0nA				
LLVIA 10X10	02	0.998	4500 V / < 0nA				
ELTOS 10x10	07	0.995	3800 V / 4nA			"old" brush cleaning process	
LLIOS IOXIO	04	0.985	4000 V / < 0nA			"old" brush cleaning process	
	01	0.969		4400 V / 0.5nA 5 sp. / 6 mn	1600 V / <0nA 6 sp. / 6 mn		
_	02	0.968		4300 V / 0.5nA 5 sp. / 10 mn	1700 V / <0nA 5 sp. / 5 mn		
ELTOS 25x25	04	0.971		4500 V / 1.4nA 5 sp. / 4 mn	1800 V / 0.4nA 6 sp. / 6 mn		
	08	0.967		4400 V / 1nA 3 sp. / 2 mn	1850 V / <0nA 6 sp. / 6 mn		
	11	0.970		4450 V / 2nA 4 sp. / 4 mn	1650 V / 0.1nA 1 sp. / 6 mn	sparks on borders at 1700 V	
	1 polished	0.96-0.98		4600 V / 2.4nA 3 sp. / 3 mn	1700 V / 0.6nA 8 sp. / 9 mn		
ELTOS 25x25	2 polished	0.96-0.98		4550 V / 2nA 6 sp. / 6 mn	1700 V / 0.7nA 13 sp. / 15 mn	19 raw FR4 sheets measured 12 sheets selected (0.96-0.98 mm)	
ELVIA 50X50 -	03	0.96-0.98		4400 V / 1.7nA 5 sp. / 5 mn	1650 V / 0.15nA 15 sp. / 20 mn	no tracking of sheet # Vs LEM #	
	04	0.96-0.98		4400 V / 1.7nA 5 sp. / 5 mn	1700 V / 0.7nA 13 sp. / 15 mn		

Spark counting was done manually. A Labview program is under development to monitor & record sparks with an automated procedure for HV increase up to BV.



# 10X10 CM<sup>2</sup> ELVIA LEMS VS ELTOS LEMS GAIN MEASUREMENTS WITH <sup>241</sup>AM SOURCE

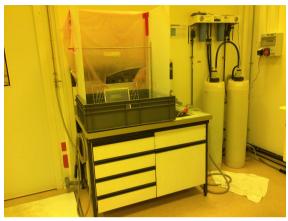






# EQUIPMENTS AT SACLAY FOR LEM CLEANING AND BAKING





Dedicated area for "Karcher" cleaning

- 720 I capacity
- Up to 300 °C
- Mechanical convection
- 1 °C accuracy
- For 80°C baking and 160 °C polymerisation



#### Heating chamber BINDER FED720

# Ultrasonic cleaning machine Multi-clean 3-120





#### « Saclay cleaning »

- Soap NGL 17.40 sp. ALU III
- 2 kW / 40 kHz
- 65°C +/- 0.1°C bath
- Successfully tested with 10x10 cm<sup>2</sup> and 25x25 cm<sup>2</sup> LEMs

# STATUS OF THE HIGH PRESSURE VESSEL WA105 FOR LEM BV AND LEM GAIN MEASUREMENTS

- On september 20<sup>th</sup>, the High-Pressure Chamber (up to 10 bars) was successfully tested for 14.3 bar with plain flanges and 4.5 bar with 4/6 vacommade DN50 HV feedthroughs flanges.
- @ 10<sup>-4</sup> mbar, 1.4 10<sup>-8</sup> Pa.m<sup>3</sup>.s<sup>-1</sup> leaks were measured with He injection with vacom HV flanges (10<sup>-6</sup>-10<sup>-7</sup> Pa.m<sup>3</sup>.s<sup>-1</sup> on the rupture disk and the safety valve).
- We are waiting for the 2 remaining Vacom HV flanges to complete the certification of the chamber with home-made DN100 signal feedthrough flanges and have it delivered at Saclay.

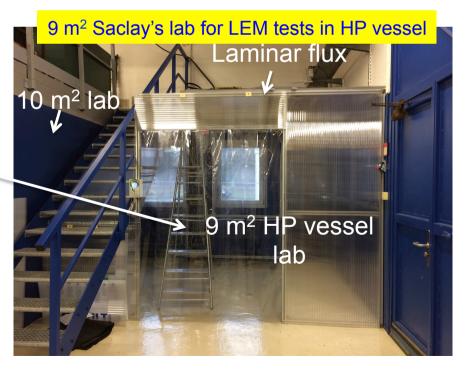




### INSTALLATION OF THE HP VESSEL @ SACLAY WA105

- Irfu-Saclay has prepared a 9 m<sup>2</sup> with a 1.2x0.6 m<sup>2</sup> laminar flux for the HP vessel. In the same hall, a 10 m<sup>2</sup> lab is dedicated to storage and assembly tasks. Another 10 m<sup>2</sup> lab is used for control-command of the tests performed in the HP vessel.
- Safety documents are currently reviewed by the Saclay Safety division for an official review on site with the vessel foreseen in 2-3 weeks.
- A tower of 6 LEMs is assembled under the laminar flux to be tested in the vessel for Breakdown Voltage qualification.





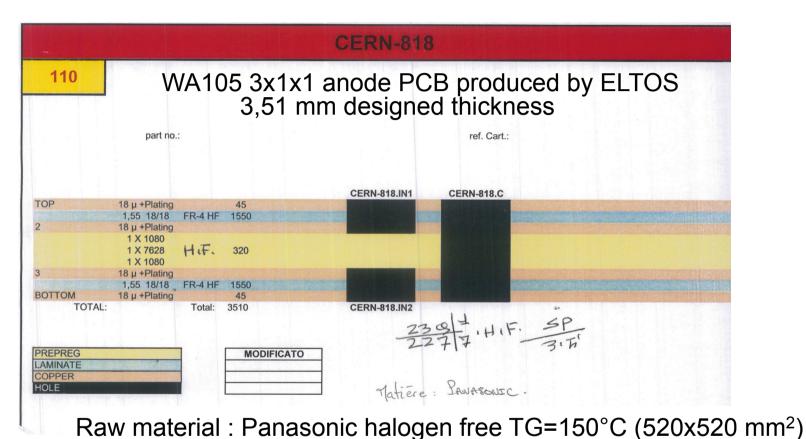


- The same process as for the preparation of LEM's production just started to gather specifications, prepare PCB production and KEL connectors soldering.
- The "good" news is that it seems the cost for ½ production may be lower than the 25 k€ threshold (≈350 €/PCB) which demands to proceed by a call for tender: 3 quotations will be asked to select a company. 2 weeks for administrative procedure will be required to make the order. Writing of the "Technical specifications" document is on-going. A rather "standard" PCB production (to be confirmed) is foreseen.
- Soldering of the KEL connectors may be done by manual positioning of connectors on brazing paste and global soldering in a convection oven. A cost of ≈30€/PCB (20 KEL connectors) for 160 anode PCBs could be reached.
- ■Q/C by the manufacturer should be standard ones driven by the IPC standards but Q/C of KEL soldering connections has to be done by WA105 (not so easy and so probably too expensive in the company).



### **ANODE PCB SPECIFICATIONS**





- Traw material. Fanasome halogen nee 10-150 C (520x520 mm)
- A.O.I. tests of inner layers before assembly & external layers at the end of the prod.
- Electrical continuities and insulations were tested on an ATG Flying Probe Tester.



### CONCLUSION



- The ELVIA company produced 10x10 and 50x50 LEMs (3x1x1 prototype design) whose performances were measured as good as ELTOS LEMs in terms of Breakdown Voltage in NTP Argon and synthetic air, and gain in NTP Argon conditions (10x10 cm²)
- This enables us to have these 2 companies in competition for WA105 LEM prod.
- The High Pressure Vessel will be soon available at Saclay to study prototypes (four 25x25 cm<sup>2</sup> LEMs side by side, 50x50 cm<sup>2</sup> LEMs with border minimization, ...) and for qualification of the WA105 production LEMs.
- The preparation of the call for tender is on-going at Saclay. The goal is to be ready for production beginning of 2017 once the launch for production will be decided.
- A internal review of the Irfu/WA105 project by the IRFU management will be held on november 21<sup>st</sup> in order to allocate ressources for half the WA105 production.
- Handling the post-production tasks (HV pin soldering, LEM cleaning, LEM BV tests) at Saclay for the full 144 LEMs is under study and requires at least 1 FTE support from the collaboration during the production phase.



### **BACKUP: PANASONIC MATERIALS**



### **Product overview**

Panasonic ideas for life

Properties  MC-100M3/EX R-156(W) R-155 R-175 R-	Product designation	F	R4 - Dicy cured	ı	FF	R4 - Phenolic cu	red				
Properties         Mc-Rheopreg         R-1551(W)         R-1550         R-1650         R-1650         R-5610         R-5610         R-4582         R-770           Standard Tg 130-140°C         Medium Tg 150°C         <		CONVENTIONAL HALOGEN FREE		HIC	HIGH PERFORMANCE			Materials		Laminate	
Medium Tg 150°C       •	Properties									R-0582	R-F775 R-F770
High Tg = 170°C  Degradation Temperature 310 330 360 364 364 340 310 400 350  Thermostable, high T 260, T 288  TCT -40°C/-125°C, 1000 cycles  TCT -40°C/-140°C, 1000 cycles  CTE (z) < 70ppm/K  CTE (z) < 55ppm/K  CTE (z) < 40ppm/K  c, D <sub>k</sub> < 3,9 at 2 GHz  High frequency application  CAF-resistant  High thermal conductivity  Leadfree	Standard Tg 130-140°C	•			•					•	
Degradation Temperature       310       330       360       364       364       340       310       400       350         Thermostable, high T 260, T 288       • • • • • • • • • • • • • • • • • • •	Medium Tg 150°C		•	•							
Thermostable, high T 260, T 288  TCT -40°C/+125°C, 1000 cycles  TCT -40°C/+140°C, 1000 cycles  CTE (z) < 70ppm/K  CTE (z) < 55ppm/K  CTE (z) < 40ppm/K  E, D, < 3,9 at 2 GHz  High frequency application  CAF-resistant  High thermal conductivity  Leadfree	High Tg ≥ 170°C					•	•	•	•		
TCT -40°C/-125°C, 1000 cycles  TCT -40°C/-140°C, 1000 cycles  CTE (z) < 70ppm/K  CTE (z) < 55ppm/K  CTE (z) < 40ppm/K  E, D, < 3,9 at 2 GHz  Tan 6 D, < 0,01 at 2 GHz  High frequency application  CAF-resistant  High thermal conductivity  Leadfree	Degradation Temperature	310	330	360	364	364	340	310	400	350	
TCT -40°C/+140°C, 1000 cycles       • • • • • • • • • • • • • • • • • • •	Thermostable, high T 260, T 288		•	•	•	•	•	•	•	•	
CTE (z) < 70ppm/K	TCT -40°C/+125°C, 1000 cycles				•						
CTE (z) < 55ppm/K	TCT -40°C/+140°C, 1000 cycles		•	•			•		•		
CTE (z) < 40ppm/K	CTE (z) < 70ppm/K	•				•		•			
ε , D <sub>k</sub> < 3,9 at 2 GHz	CTE (z) < 55ppm/K			•	•		•		•		
Tan 5 Dt < 0,01 at 2 GHz  High frequency application  CAF-resistant  High thermal conductivity  Leadfree	CTE (z) < 40ppm/K		•								
High frequency application  CAF-resistant  High thermal conductivity  Leadfree	ε , D <sub>k</sub> < 3,9 at 2 GHz							•	•	0	
CAF-resistant High thermal conductivity Leadfree	Tan & D₁ < 0,01 at 2 GHz								•		
High thermal conductivity  Leadfree	High frequency application							•	•		
Leadfree	CAF-resistant		•	•	•	•	•	•	•		
	High thermal conductivity		•	•	•		•				
RoHS conform	Leadfree		•	•	•	•	•	•	•	•	
	RoH\$ conform	•	•	•	•	•	•	•	•	•	•

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Rev.4 30.10.2008

Walchshofer /092009 Slide 17

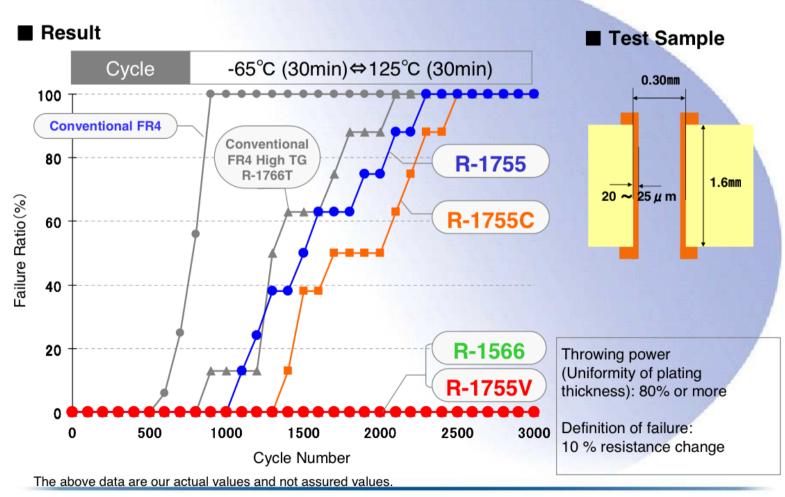


### **BACKUP: PANASONIC MATERIALS**



### Through hole reliability - 1





Panasonic Electric Works Electronic Materials Europe GmbH

Walchshofer /092009 Slide 10